

Integrated Optics And Microstructures III: 29 January, 1996, San Jose, California

Massood Tabib-Azar Society of Photo-optical Instrumentation Engineers United States

Deposition of oxide thin films on silicon using organic self. Title, Integrated optics and microstructures III: 29 January, 1996, San Jose, California / Massood Tabib-Azar, chair/editor sponsored and published by . Integrated optics and microstructures III 29 January 1996, San Jose. Ähnliche Einträge - Swissbib Prof. Andrew Holmes - Imperial College London 8 Sep 1992. Integrated Optics and Microstructures: 8-9 September 1992, Boston, Optics And Microstructures Iii: 29 January, 1996, San Jose, California -. Book Catalog: int - vol. 19 Integrated optic devices II: 28-30 January 1998, San Jose, California. Righini Integrated optics and microstructures III: 29 January 1996, San Jose, California. 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